2018년 2월 7일(수), 16:15-17:30 Room B (태백II+III, 5층)

## H. Display and Imaging Technologies 분과 [WB4-H] Display and Imaging

좌장: 최병덕 교수(한양대학교)

WB4-H-1 16:15-16:30	High-Performance Solution-Processed Indium-Gallium-Zinc-Oxide Thin-Film Transistors on Flexible Substrates Operating at Low-Voltage Byoung-soo Yu and Tae-Jun Ha Department of Electronic Materials Engineering, Kwangwoon University
WB4-H-2 16:30-16:45	Foreground Protection-Based Motion Vector Refinement for Frame Rate Up-Conversion Ho Sub Lee and Young Hwan Kim Department of Electrical Engineering, POSTECH
WB4-H-3 16:45-17:00	Optimization of Organic Materials (Red, Green, Blue) for CMOS Image Sensor Hyo-Won BAIK <sup>1</sup> , Seung-Hyun SONG <sup>2</sup> , Joo-Hyeong PARK <sup>2</sup> , Min-Won KIM <sup>2</sup> , Hyo-Jun KWON <sup>2</sup> , Jae-Gon KIM <sup>1</sup> , Ui-Hyeon Jung <sup>2</sup> , and Jea-Gun PARK <sup>2</sup> Department of Nanoscale Semiconductor Eng., Hanyang University, Department of Electronics and Computer Eng., Hanyang University
WB4-H-4 17:00-17:15	Improvement of Photo-sensitivity in CMOS Image Sensor via Pyramidal Anti-Reflective Surface Structure  Jiho Choi <sup>1</sup> , Il-Hwan Kim <sup>1</sup> , Jun-Seong Park <sup>1</sup> , Hyeonju Shin <sup>2</sup> , and Jea-Gun Park <sup>1,2</sup> <sup>1</sup> Department of Electronic and Computer Eng., Hanyang University, <sup>2</sup> Department of Nanoscale Semiconductor Eng., Hanyang University
WB4-H-5 17:15-17:30	다중초점 영상 검사를 위한 근사기법 Hyein Kim <sup>1</sup> , Yunjin Park <sup>1</sup> , Hyoseon Yang <sup>2</sup> , Byeongseon Jeong <sup>2</sup> , and Jungho Yoon <sup>1</sup> <sup>1</sup> Department of Mathematics, Ewha Womans University, <sup>2</sup> Institute of Mathematical Sciences, Ewha Womans University